

Notice of References Cited	Application/Control No. 10/755,742		Applicant(s)/Patent Under Reexamination SMAUS ET AL.	
	Examiner Daniel Kim		Art Unit 2185	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0125613	06-2005	Kim et al.	711/125
*	B	US-6,345,295	02-2002	Beardsley et al.	709/224
*	C	US-5,930,497	07-1999	Cherian et al.	703/21
*	D	US-6,578,128	06-2003	Arsenault et al.	711/202
*	E	US-6,973,543	12-2005	Hughes, William Alexander	711/141
*	F	US-2004/0216091	10-2004	Groeschel, Michael John	717/128
*	G	US-6,233,678	05-2001	Bala, Vasanth	712/240
*	H	US-5,210,843	05-1993	Ayers, David J.	711/128
*	I	US-6,167,536	12-2000	Mann, Daniel Peter	714/45
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.